

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)	Group Art Unit: 2874
Koichiro TANAKA et al.)	Examiner: Michael J. Stahl
Serial No. 10/827,449)	CERTIFICATE OF MAILING I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on January 17, 2007. Add Adam Adamper
Filed: April 20, 2004)	
For: BEAM HOMOGENIZER, LASER)	
IRRADIATION APPRATUS, AND)	
METHOD FOR MANUFACTURING)	
SEMICONDUCTOR DEVICE)	

REQUEST FOR CORRECTED FILING RECEIPT

Honorable Commissioner of Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

The Filing Receipt received in the above-identified application has errors thereon due to Patent Office error as shown in red on the attached copy.

In view of the above, it is requested that a Corrected Filing Receipt be issued.

Respectfully submitted,

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FILING OR 371 **DRAWINGS** TOT CLMS ATTY.DOCKET NO IND CLMS APPL NO. ART UNIT FIL FEE REC'D (c) DATE 48 9 1790 2874 0756-7293 10/827.449 04/20/2004

CONFIRMATION NO. 2793

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FILING RECEIPT OC000000013103624*

Date Mailed: 06/29/2004

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Applicant(s)

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Assignment For Published Patent Application

Semiconductor Energy Laboratory Co., Ltd., Atsugi-shi, JAPAN;

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JAPAN 2003-120782 04/24/2003 JAPAN 2003-342803 10/01/2003

If Required, Foreign Filing License Granted: 06/29/2004

Projected Publication Date: 10/28/2004

Non-Publication Request: No

Early Publication Request: No

Title

Beam homogenizer, laser irradiation apparatus, and method for manufacturing semiconductor device

Preliminary Class

385

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